

<p>Substitute for form 1449A/PTO</p> <p>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</p> <p>(use as many sheets as necessary)</p>				<p>Complete if Known</p>	
Sheet	1	of	2	Application Number	10/826,018
				Filing Date	
				First Named Inventor	Chiwoe Wayne Lo
				Art Unit	-2861 2881
				Examiner Name	Judy Nguyen Jack Bernagh
				Attorney Docket Number	6317P090D2

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

Examiner Signature	Jack Berman	Date Considered	9/28/2005
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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

Sheet

2

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NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
JB		T.R. GROVES, et al., "Distributed, multiple variable shaped electron beam column for high throughput maskless lithography", J. Vac. Sci. Technol., B 16(6), Nov/Dec 2000, pp. 3168-3173	
JB		E. YIN, et al., "Electron optical column for a multicolumn, multibeam direct-write electron beam lithography system", J. Vac. Sci. Technol., B 18(6), Nov/Dec 2000, pp. 3126-3131	
JB		A. KHURSHEE, "Permanent magnet objective lenses for multicolumn electron-beam systems", Review of Scientific Instruments, Vol. 72, Number 4, April 2001, pp. 2106-2109	
JB		EIICHI GOTO et al., "MOL (moving objective lens) Formulation of deflective aberration free system", Optik, 48 (1977), No. 3, pp. 255-270	

Examiner Signature	<i>Jack Berman</i>	Date Considered	9/28/2003
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